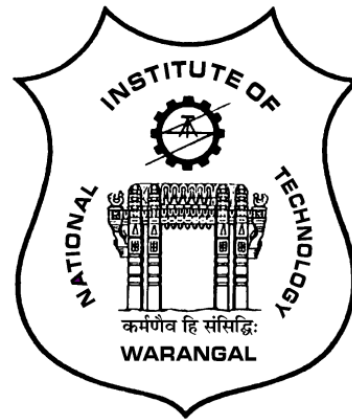


A PROJECT REVIEW
ON
**PERFORMANCE OF COPPER AND COPPER TUNGSTEN
ELECTRODES WITH DIFFERENT DIELECTRICS USING TAGUCHI
BASED TOPSIS**



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MANUFACTURING ENGINEERING

INTRODUCTION

- ❖ Electro Discharge Machining (EDM) is a traditional machining technology and is one of the most efficient technologies for fabricating components.
- ❖ EDM is the most widely and successfully used method for machining difficult to machine materials like super alloys and titanium alloys.
- ❖ Titanium and its alloys have many attractive properties, including a high specific strength, excellent corrosion resistance and cryogenic properties.
- ❖ Titanium alloy, which is a difficult-to-machine material, can be machined effectively by EDM.



LITERATURE REVIEW

- Biing Hwa Yan , Hsien Chung Tsai (2005), Study investigates the influence of the machining characteristics on pure titanium metals using EDM with the addition of urea into distilled water.
- Anand Pandey et. Al (2010), Explained Present manufacturing industries are facing challenges from these advanced materials viz. super alloys.
- LUO Yong et.al (2007), Described about Three different nitrogen ion doses were implanted into a Ti6Al4V alloy to improve its mechanical surface properties
- I.Puertas, C.J.Luis,(2003), worked on study on the machining parameters optimization of electrical discharge machining.
- F. Hosseinzadeh Lotfi et al [2009], the aim of this paper is to extend the TOPSIS method for decision-making problems with Fuzzy data.



OBJECTIVE OF PRESENT WORK

- To investigate the performance of copper and copper tungsten as electrodes in EDM characteristics of Titanium alloy [Ti–6Al–4V] using kerosene, distilled water and urea solution as the dielectrics.
- To attain higher Material removal rate, lower Electrode wear rate, while machining Titanium alloy [Ti–6Al–4V] using copper tungsten as electrode with different dielectrics.



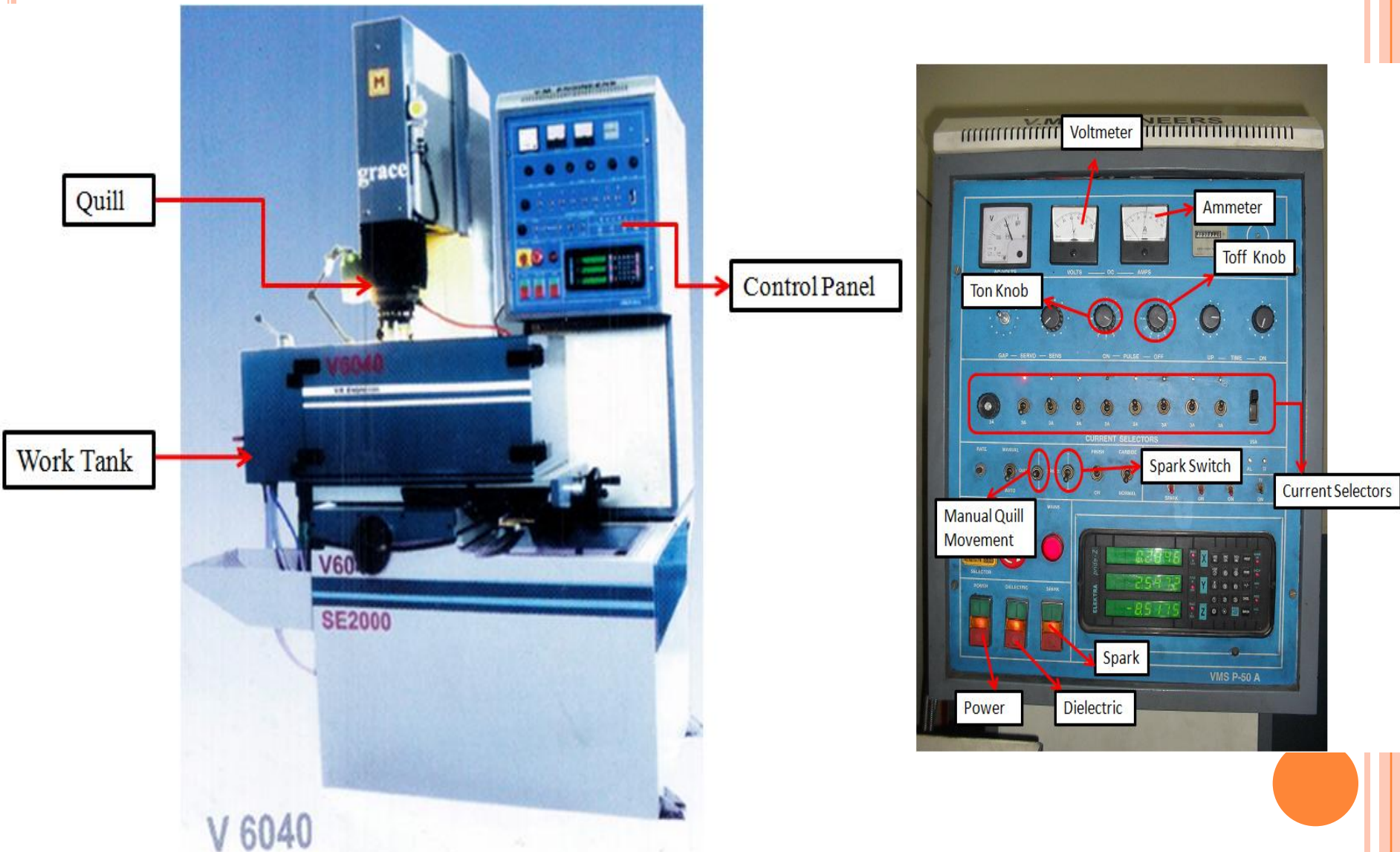
DETAILS OF THE WORK

MACHINE TOOL DETAILS

SPECIFICATIONS OF MACHINE TOOL (EDM V 6040)	UNITS	V 6040
TABLE DIMENSION	MM	600 x 400
WORK TANK DIMENSION	MM	900 x 550 x 375
X TRAVEL	MM	400
Y TRAVEL	MM	275
Z TRAVEL	MM	220
BACK SLIDE TRAVEL	MM	200
MAX. TABLE LOADING	KGS	600
DI-ELECTRIC CAPACITY	LTS	300
NORMAL CURRENT	AMPS	50
SPECIFICATIONS OF POWER SUPPLY	UNITS	P50
MAX. CURRENT	AMPS	50
MAX. OPEN CKT. VOLTAGE	VOLTS	75-80
MATERIAL CU	MM ³ /MIN	300
REMOVAL RATE GR		350
SURFACE FINISH	CLA MICRON	0.8
POWER CONSUMPTION	KW	3
PULSE ON/OFF TIME		IN 10 STEPS



PHOTOGRAPH VIEW OF EXPERIMENTAL SETUP



WORK MATERIAL

Titanium Alloy [Ti-6Al-4V]

Composition

C	<0.08%
Fe	<0.25%
N ₂	<0.05%
O ₂	<0.2%
Al	5.5-6.76%
V	3.5-4.5%
H ₂ (sheet)	<0.015%
H ₂ (bar)	<0.0125%
H ₂ (billet)	<0.01%
Ti	Balance

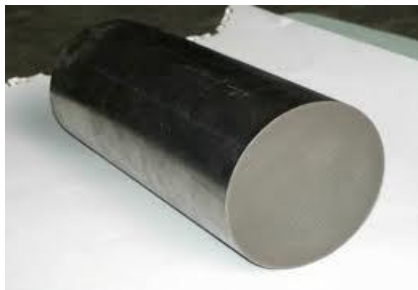
Mechanical properties

Tensile Strength MPa (ksi)	897 (130)	1000 (145)
0.2% Proof Stress MPa (ksi)	828 (120)	910 (132)
Elongation Over 2 Inches %	10	18
Reduction in Area %	20	
Elastic Modulus GPa (Msi)		114 (17)
Hardness Rockwell C		36
Specified Radius <0.070 in x Thickness		4.5
Specified Radius >0.070 in x Thickness		5.0
Welded Radius x Thickness	6	
Charpy, V-Notch Impact J (ft.lbf)		24 (18)

Applications

- Aerospace industry
- Biomechanical
- Marine applications
- Chemical industry
- Petrochemical
- Body Jewelers
- Sports Equipment

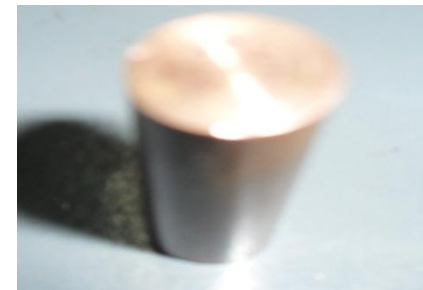
Work piece



Copper electrode

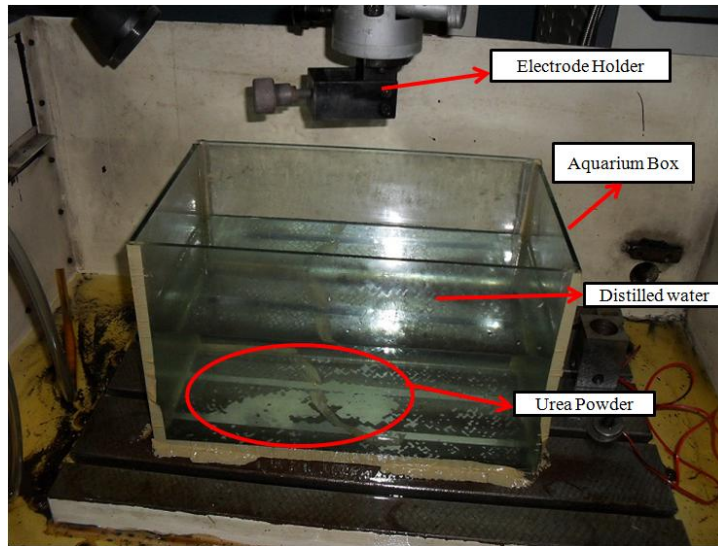


Copper tungsten electrode



PREPARATION OF DIELECTRIC

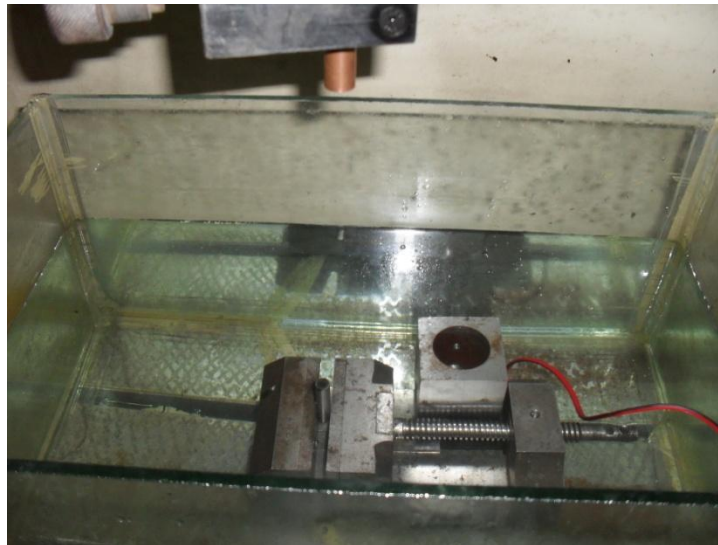
- Urea solution is prepared of concentration 10 grams urea powder in 1 liter of distilled water.



Urea Properties

Molar mass	60.06 g mol ⁻¹
Appearance	White solid
Density	1.32 g/cm ³
Melting point	133–135 C
Solubility in water	51,8 g/100 ml (20 C)

- Distilled water



Distilled water Properties

Density (1000 Kg/m ³)	1
Viscosity (Pa-s)	1.79*10e-3
Kinematic Viscosity (m ² /s)	1.79*10e-6
Temperature	0



TAGUCHI DESIGN OF EXPERIMENTS PROCESS STEPS

- Genichi Taguchi, a Japanese engineer, has developed the Taguchi method for the application of design of experiment.
- Taguchi methods is the method used for the optimization of experimental designs for performance quality and cost.
- Taguchi parameter design can optimize the performance characteristics through the settings of design parameters and reduce the sensitivity of the system performance to sources of variation.

Steps followed by the taguchi method

1. Problem identification
2. Objectives of the project work
3. Selecting Quantity characteristics
4. Selecting the process parameters that may influence quantity characteristics



5. Identifying Control factors

Control factors

Peak current(Amps)
 Ton(Micro secs)
 Gap voltage(Volts)
 Electrode
 Dielectric

Noise factors

Environmental (Room) conditions
 Homogeneity of work or tool material
 Tool and Machine Tool Rigidity
 Tool & Work Material

6. Selecting levels for control factors

Control factors	Level 1	Level 2	Level 3
Electrode	CU	CU+W	
Dielectric	Kerosene	Distilled water	Urea solution
Peak current(Amp)	3	5	7
Ton(Micro secs)	50	100	200
Gap voltage(Volts)	35	40	45

7. Selecting Orthogonal Array and Assign Factors

Here we have five factors and three levels for each factor so L18 Mixed Orthogonal array can be selected and factors are assigned.

8. Conducting Tests as per trials in Orthogonal Array

9. Analyze the results of experimentation trials

10. Conduct confirmation Experiment

Experimental Design

Mixed level L_{18}

SL.No	A	B	C			D	E	
1	1	1	1	1	1	1	1	1
2	1	1	2	2	2	2	2	2
3	1	1	3	3	3	3	3	3
4	1	2	1	1	2	2	3	3
5	1	2	2	2	3	3	1	1
6	1	2	3	3	1	1	2	2
7	1	3	1	2	1	3	2	3
8	1	3	2	3	2	1	3	1
9	1	3	3	1	3	2	1	2
10	2	1	1	3	3	2	2	1
11	2	1	2	1	1	3	3	2
12	2	1	3	2	2	1	1	3
13	2	2	1	2	3	1	3	2
14	2	2	2	3	1	2	1	3
15	2	2	3	1	2	3	2	1
16	2	3	1	3	2	3	1	2
17	2	3	2	1	3	1	2	3
18	2	3	3	2	1	2	3	1

Factors were assigned in A,B,C,D,E column means

A-Electrode, B-Dielectric, C-Peak current, D-Ton, E-Gap voltage



Sl. No	Electrode	Dielectric	Peak current(Amps)	Ton(Mic.sec)	Gap voltage(Volt)
1	CU	K	3	50	35
2	CU	K	5	100	40
3	CU	K	7	200	45
4	CU	D	3	100	45
5	CU	D	5	200	35
6	CU	D	7	50	40
7	CU	U	3	200	40
8	CU	U	5	50	45
9	CU	U	7	100	35
10	CU+W	K	3	100	40
11	CU+W	K	5	200	45
12	CU+W	K	7	50	35
13	CU+W	D	3	50	45
14	CU+W	D	5	100	35
15	CU+W	D	7	200	40
16	CU+W	U	3	200	35
17	CU+W	U	5	50	40
18	CU+W	U	7	100	45

Conducting the Experiments

- In this step the experiment was conducted for the five Process Parameters using the *L9* orthogonal array.
- In this study experiments were conducted in two halves. First 9 experiments Copper was taken as electrode and for other 9 experiments copper Tungsten was taken.

RESULTS AND DISCUSSION

COPPER[CU] MRR AND EWR [L₉]

Dielectric	Peak current	Ton	Gap voltage	MRR	EWR
K	3	50	35	0.8	0.6
K	5	100	40	1	1
K	7	200	45	2	3
D	3	100	45	6	4
D	5	200	35	8	5
D	7	50	40	12	7
U	3	200	40	7	6
U	5	50	45	9	7
U	7	100	35	15	8

COPPER TUNGSTEN [CU+W] MRR AND EWR [L₉]

Dielectric	Peak current	Ton	Gap voltage	MRR	EWR
K	3	100	40	3	1
K	5	200	45	4	2
K	7	50	35	8	4
D	3	50	45	3	4
D	5	100	35	6	5
D	7	200	40	14	6
U	3	200	35	8	5
U	5	50	40	6	6
U	7	100	45	18	7



CU&CU+W MRR, EWR [L₁₈]

Sl. No	Electrode	Dielectric	Peak current	Ton	Gap voltage	MRR	EWR
1	CU	K	3	50	35	0.8	0.6
2	CU	K	5	100	40	1	1
3	CU	K	7	200	45	2	3
4	CU	D	3	100	45	6	4
5	CU	D	5	200	35	8	5
6	CU	D	7	50	40	12	7
7	CU	U	3	200	40	7	6
8	CU	U	5	50	45	9	7
9	CU	U	7	100	35	15	8
10	CU+W	K	3	100	40	3	1
11	CU+W	K	5	200	45	4	2
12	CU+W	K	7	50	35	8	4
13	CU+W	D	3	50	45	3	4
14	CU+W	D	5	100	35	6	5
15	CU+W	D	7	200	40	14	6
16	CU+W	U	3	200	35	8	5
17	CU+W	U	5	50	40	6	6
18	CU+W	U	7	100	45	18	7

Analyzing the experiment results

- In this step the result of the Experiment are studied using following two steps.
 1. Analysis of Means
 2. Analysis of variance (ANOVA)
- Based on the results of the Mean and ANOVA analyses, optimal settings of the control parameters for MRR and EWR are obtained.

Analysis of Means

$$\text{Mean A, } 1 = (\text{MRR1} + \text{MRR2} + \text{MRR3}) / 3$$

$$\text{Mean B, } 1 = (\text{MRR4} + \text{MRR5} + \text{MRR6}) / 3$$

$$\text{Mean C, } 1 = (\text{MRR7} + \text{MRR8} + \text{MRR9}) / 3$$



Mean Response table for CU MRR

Level	Dielectric	Peak current	Ton	Gap voltage
1	1.267	4.600	7.267	7.933
2	8.667	6.000	7.333	6.667
3	10.333	9.667	5.667	5.667
Delta	9.067	5.067	1.667	2.267
Rank	1	2	4	3

Optimum process parameters: **A3, B3, C2, D1**

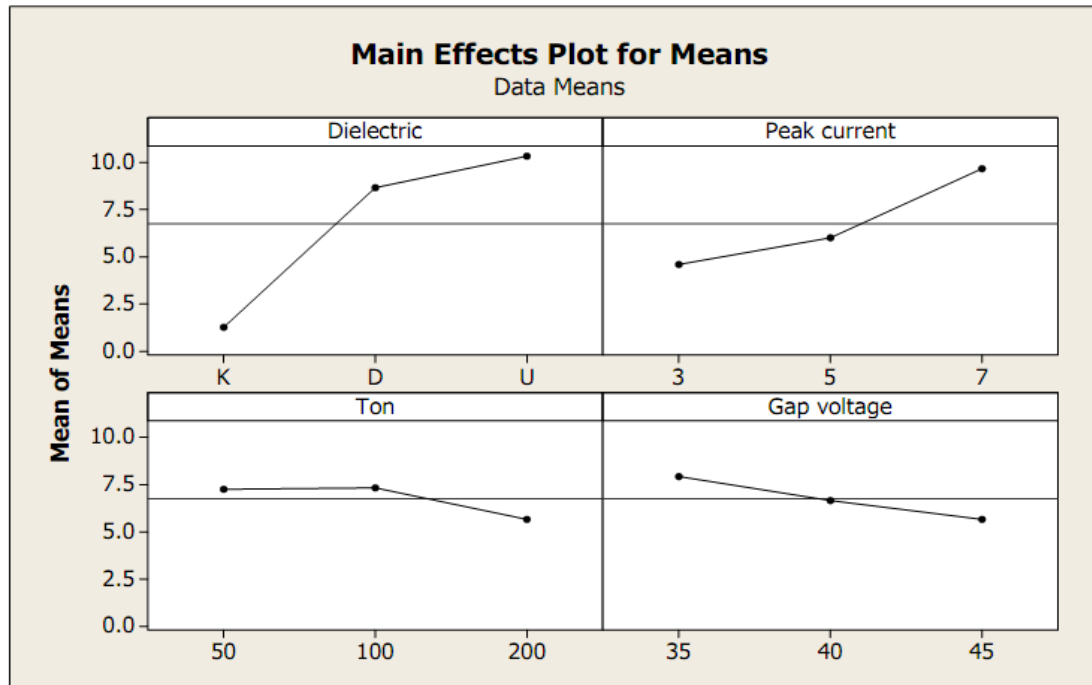
Dielectric = Urea solution

Peak current = 7 Amps

Ton = 100 Micro seconds

Gap voltage = 35 Volts

Mean Response graph for CU MRR Vs Control Parameters



Mean Response table for CU EWR

Level	Dielectric	Peak current	Ton	Gap voltage
1	1.533	3.533	4.333	4.533
2	5.333	4.333	4.867	4.667
3	7.000	6.000	4.667	4.867
Delta	5.467	2.467	0.533	0.133
Rank	1	2	3	4

Optimum process parameters: **A1, B1, C1, D1**

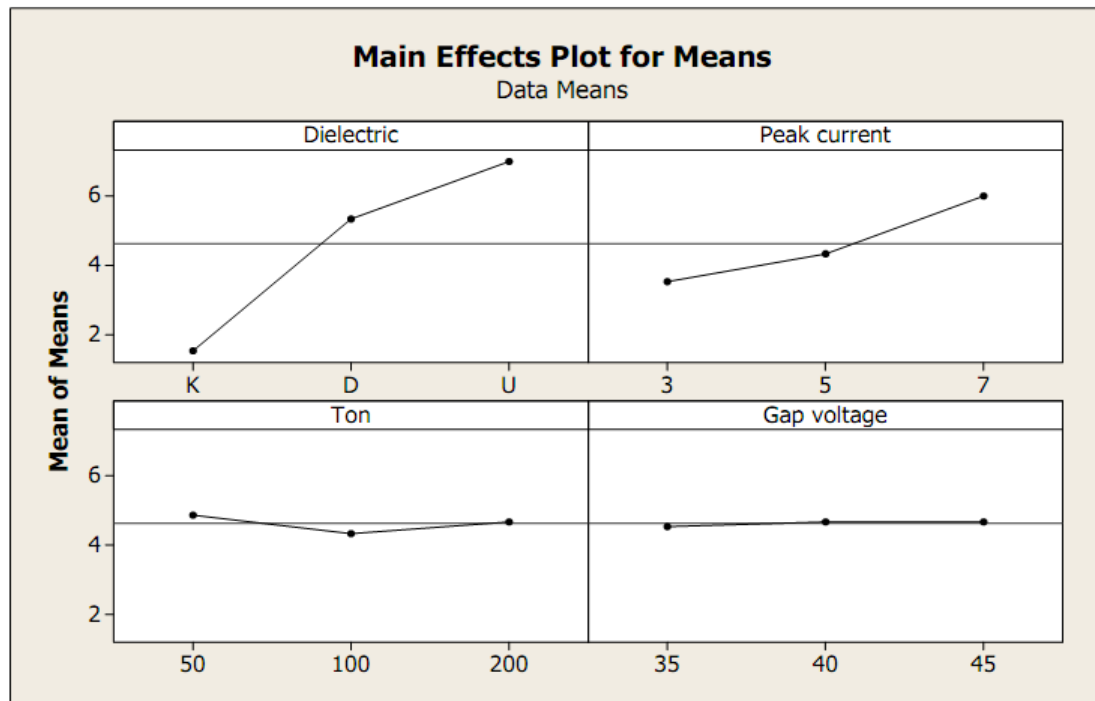
Dielectric = Kerosene

Peak current = 3 Amps

Ton = 50 Micro seconds

Gap voltage = 35 Volts

Mean Response graph for CU EWR Vs Control Parameters



Mean Response table for CU+W MRR

Level	Dielectric	Peak current	Ton	Gap voltage
1	5.000	4.667	5.667	7.333
2	7.667	5.333	9.000	7.667
3	10.667	13.333	8.667	8.333
Delta	5.667	8.667	3.333	1
Rank	2	1	3	4

Optimum process parameters: **A3, B3, C2, D3**

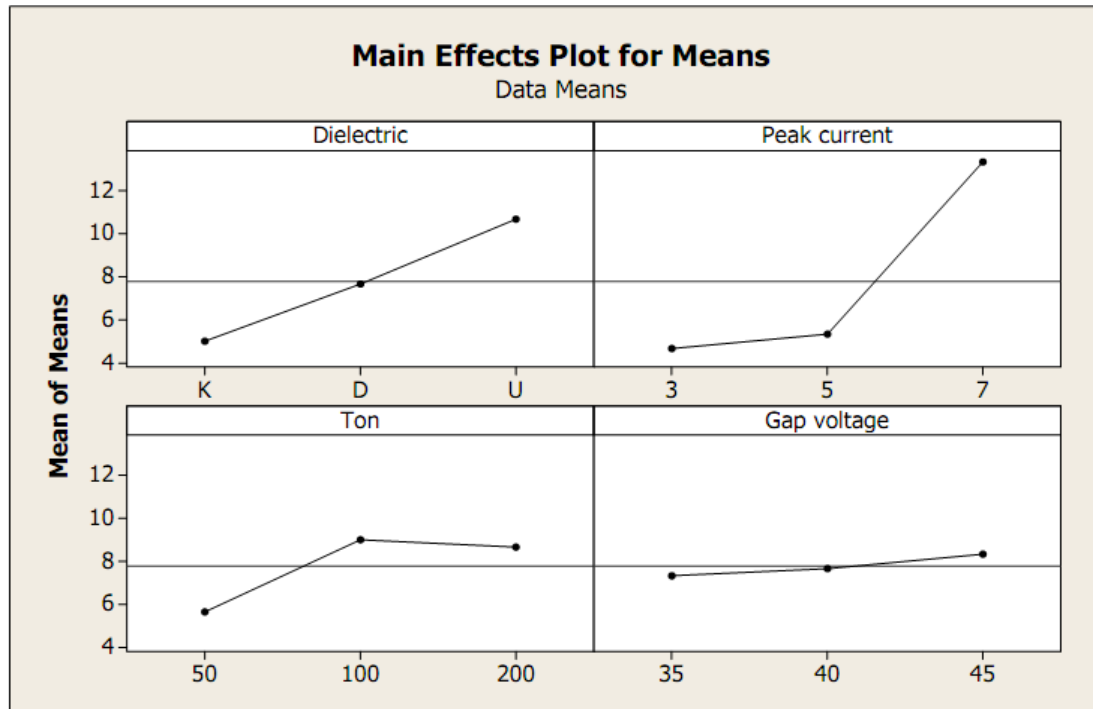
Dielectric = Urea solution

Peak current = 7 Amps

Ton = 100 Micro seconds

Gap voltage = 45 Volts

Mean Response graph for CU+W MRR Vs Control Parameters



Mean Response table for CU+W EWR

Level	Dielectric	Peak current	Ton	Gap voltage
1	2.333	3.333	4.667	4.667
2	5.000	4.333	4.333	4.333
3	6.000	5.667	4.334	4.345
Delta	3.667	2.333	0.333	0.333
Rank	1	2	3.5	3.5

Optimum process parameters: **A1, B1, C2, D2**

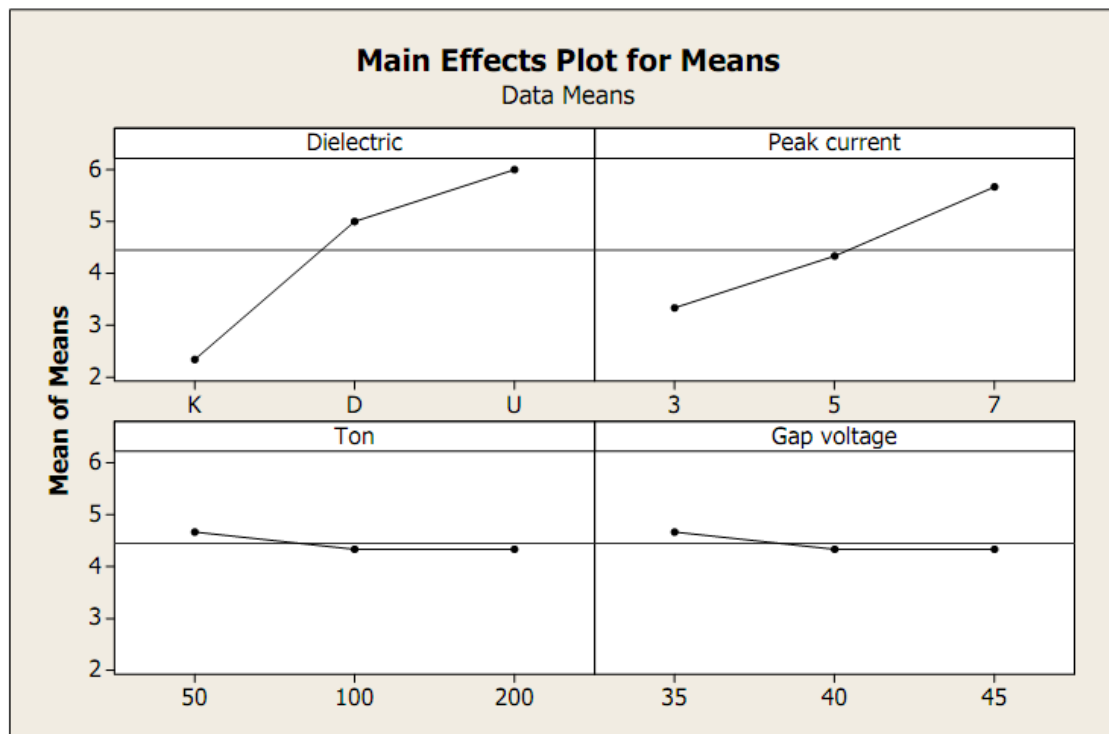
Dielectric = Kerosene

Peak current = 3 Amps

Ton = 50 Micro seconds

Gap voltage = 40 Volts

Mean Response graph for CU+W EWR Vs Control Parameters



Mean Response table for CU&CU+W MRR

Level	Electrode	Dielectric	Peak current	Ton	Gap voltage
1	6.756	3.133	4.633	6.467	7.000
2	7.778	8.167	5.667	8.167	7.167
3		10.500	11.500	7.167	7.633
Delta		7.367	6.867	1.7	0.633
Rank	4	1	2	3	5

Optimum process parameters:

A2, B3, C3,D2,E3

Electrode = Copper Tungsten (CU+W)

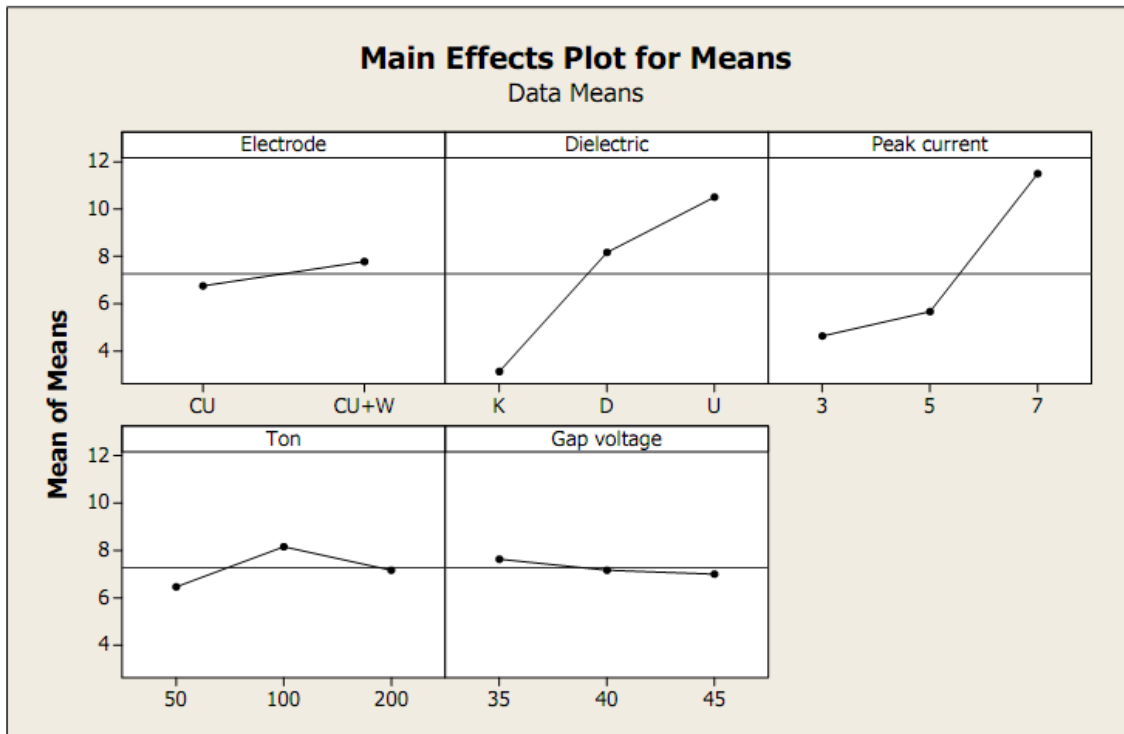
Dielectric = Urea solution

Peak current = 7 Amps

Ton = 100 Micro seconds

Gap voltage = 45 Volts

Mean Response graph for CU&CU+W MRR Vs Control Parameters



Mean Response table for CU&CU+W EWR

Level	Electrode	Dielectric	Peak current	Ton	Gap voltage
1	4.622	1.933	3.433	4.767	4.60
2	4.444	5.167	4.333	4.333	4.500
3		6.500	5.833	4.500	4.550
Delta		4.567	2.40	0.433	0.1
Rank	4	1	2	3	5

Optimum process parameters:

A2, B1, C1,D2,E2

Electrode = Copper Tungsten (CU+W)

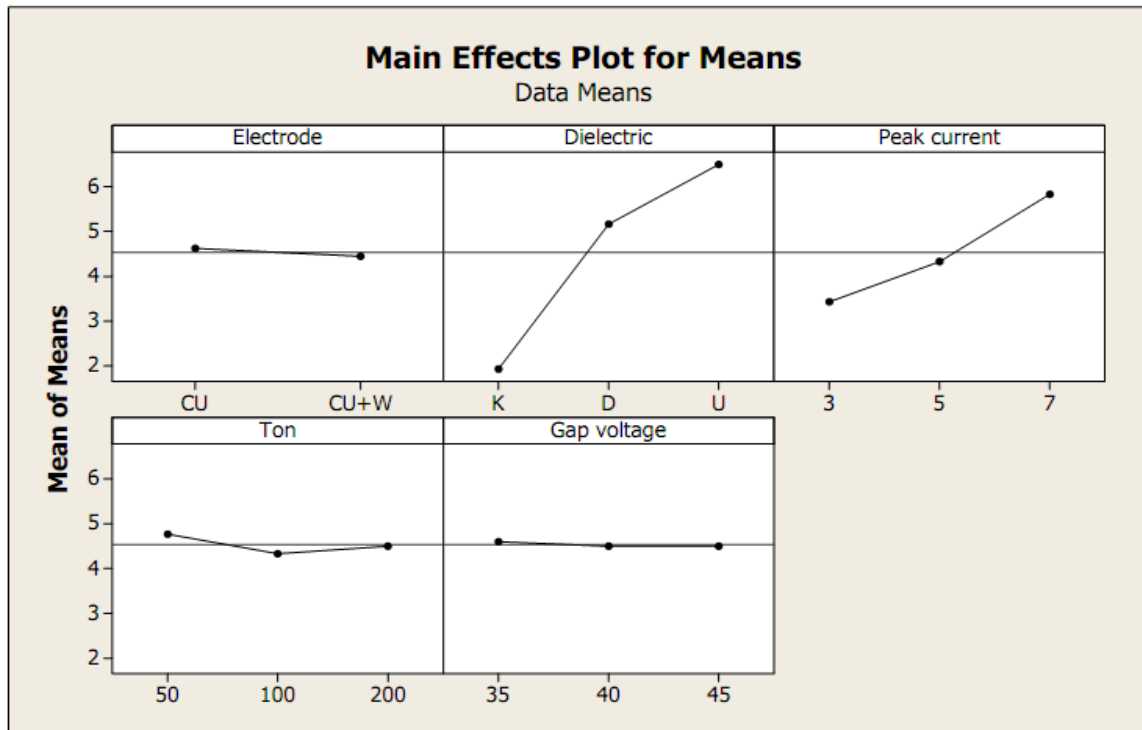
Dielectric = Kerosene

Peak current = 3 Amps

Ton = 100 Micro seconds

Gap voltage = 40 Volts

Mean Response graph for CU&CU+W EWR Vs Control Parameters



ANALYSIS OF VARIANCE

- The purpose of the analysis of variance (ANOVA) is to investigate which design parameters significantly affect the quality characteristic.
- To calculate the sum of the squares, mean squares and contributions by each of the design parameters from response table.
- First, Average calculated as:

$$\text{Average } (n_m) = (\text{MRR1} + \text{MRR2} + \text{MRR3} + \text{MRR4} + \text{MRR5} + \text{MRR6} + \text{MRR7} + \text{MRR8} + \text{MRR9}) / 9$$

$$\text{Total Sum of Squares } (S_T) = \sum_{i=1}^9 (\text{MRR})$$

$$\text{Sum of squares due to the mean } (S_m) = n * (n_m)^2$$

$$\text{Sum of squares due to factors } (S_A) = n_{A1} * A_1^2 + n_{A2} * A_2^2 + n_{A3} * A_3^2 - S_m$$

$$\text{Degree of freedom (DOF)} = \text{no of levels} - 1$$

$$\text{Mean sum of squares } (M_{Qa}) = S_A / \text{DOF}$$

$$\% \text{ Contribution } (P) = S_A / S_t \quad \text{where } S_t = S_T - S_m$$



Results of the ANOVA for CU

MRR

Sym bol	Process parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Dielectric	2	140.41	70.205	72.16
B	Peak current	2	41.77	20.885	21.46
C	Ton	2	6.03	3.015	3.09
D	Gap voltage	2	8.42	4.21	4.32
Error		0	-	-	-
St		8	194.58	-	-
Mean			410.06	-	-
ST			604.64	-	-

EWR

Sym bol	Process parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Dielectric	2	47.77	23.885	83.41
B	Peak current	2	9.68	4.84	16.90
C	Ton	2	0.64	0.32	1.11
D	Gap voltage	2	5.96	2.98	10.40
Error		0	-	-	-
St		8	57.27	-	-
Mean			192.09	-	-
ST			249.36	-	-



Results of the ANOVA for CU+W

MRR

EWR

Sym bol	Process parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Dielectric	2	47.28	23.64	22.46
B	Peak Current	2	139.22	69.61	66.53
C	Ton	2	53.27	26.63	25.45
D	Gap Voltage	2	1.23	0.61	0.50
Error		0	-	-	-
St		8	209.25	-	-
Mean			544.75	-	-
ST			754	-	-

Sym bol	Process parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Dielectric	2	21.55	10.77	71.28
B	Peak Current	2	8.22	4.11	27.19
C	Ton	2	0.22	0.11	0.72
D	Gap Voltage	2	0.22	0.11	0.72
Error		0	-	-	-
St		8	30.23	-	-
Mean			177.77	-	-
ST			208	-	-



Results of the ANOVA for CU & CU+W

MRR

Sym bol	Process Parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Electrode	1	6.53	6.53	1.59
B	Dielectric	2	171.86	85.93	41.92
C	Peak Current	2	166.24	83.12	40.55
D	Ton	2	10.59	5.29	2.58
E	Gap Voltage	2	3.04	1.52	0.74
Error		8	-	-	-
St		17	409.91	-	-
Mean			948.73	-	-
ST			1358.64	-	-

EWR

Sym bol	Process Parameters	DOF	Sum of squares	Mean squares	Contribution (%)
A	Electrode	1	0.63	0.63	0.72
B	Dielectric	2	66.73	10.77	75.83
C	Peak Current	2	18.13	4.11	20.60
D	Ton	2	1.12	0.11	1.27
E	Gap Voltage	2	0.59	0.11	0.6
Error		8	-	-	-
St		17	87.99	-	-
Mean			369.37	-	-
ST			457.36	-	-



TOPSIS METHOD

➤ TOPSIS (Technique for order preference by similarity to an ideal solution) considers the distances to the ideal solution and negative ideal solution regarding each alternative and selects the most relative closeness to the ideal solution as the best alternative.

Step 1 Decision matrix

$$D = \begin{matrix} & F_1 & F_2 & \dots & F_n \\ \begin{matrix} A_1 \\ A_2 \\ \vdots \\ A_n \end{matrix} & \begin{bmatrix} f_{11} & f_{12} & \dots & f_{1n} \\ f_{21} & f_{22} & \dots & f_{2n} \\ \vdots & \vdots & \ddots & \vdots \\ f_{m1} & f_{m2} & \dots & f_{mn} \end{bmatrix} \end{matrix}$$

Step 2 Normalized Decision matrix

$$r_{ij} = f_{ij} / (\sum_{j=1}^n f_{ij}^2)^{1/2}$$

Step 3 Weighted Normalized Decision matrix

$$v_{ij} = w_{ij} r_{ij}$$

Step 4 Positive Ideal Solution

$$V^+ = \{v_1^+, \dots, v_n^+\} = \{(Max v_{ij} | j \in J), (Min v_{ij} | j \in J')\}$$

Negative Ideal Solution

$$V^- = \{v_1^-, \dots, v_n^-\} = \{(Min v_{ij} | j \in J), (Max v_{ij} | j \in J')\}$$



Step 5 Separation measure of each alternative from the PIS

$$D_i^+ = \sqrt{\sum_{j=1}^n (v_{ij} - v_j^+)^2}, \quad i = 1, \dots, m$$

Separation measure of each alternative from the NIS

$$D_i^- = \sqrt{\sum_{j=1}^n (v_{ij} - v_j^-)^2}, \quad i = 1, \dots, m$$

Step 6 Relative closeness of the alternative A_i with respect to PIS

$$\bar{C}_i = \frac{D_i^-}{D_i^+ + D_i^-}$$

- Where the index value of C_i lies between 0 and 1.
- The larger the index value, the better the performance of the Alternatives.



Decision Matrix [CU]						Normalized decision matrix [CU]					
Dielectric	Peak current	Ton	Gap voltage	MRR	EWR	Dielectric	Peak current	Ton	Gap voltage	MRR	EWR
K	3	50	35	0.8	0.6	K	0.190117	0.125988	0.290159	0.032534	0.037996
K	5	100	40	1	1	K	0.316862	0.251976	0.331611	0.040668	0.063327
K	7	200	45	2	3	K	0.443607	0.503953	0.373062	0.081336	0.18998
D	3	100	45	6	4	D	0.190117	0.251976	0.373062	0.244007	0.253307
D	5	200	35	8	5	D	0.316862	0.503953	0.290159	0.325343	0.316633
D	7	50	40	12	7	D	0.443607	0.125988	0.331611	0.488015	0.443287
U	3	200	40	7	6	U	0.190117	0.503953	0.331611	0.284675	0.37996
U	5	50	45	9	7	U	0.316862	0.125988	0.373062	0.366011	0.443287
U	7	100	35	15	8	U	0.443607	0.251976	0.290159	0.610018	0.506613

Weighted normalized decision matrix [CU]

Dielectric	Peak current	Ton	Gap voltage	MRR	EWR
K	0.057035	0.025198	0.023213	0.013014	0.00076
K	0.095059	0.050395	0.026529	0.016267	0.001267
K	0.133082	0.100791	0.029845	0.032534	0.0038
D	0.057035	0.050395	0.029845	0.097603	0.005066
D	0.095059	0.100791	0.023213	0.130137	0.006333
D	0.133082	0.025198	0.026529	0.195206	0.008866
U	0.057035	0.100791	0.026529	0.11387	0.007599
U	0.095059	0.025198	0.029845	0.146404	0.008866

Relative closeness to the ideal solution for [CU]

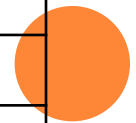
Electrode	Dielectric	Relative closeness
CU	K	0
CU	K	0.162387
CU	K	0.3405
CU	D	0.339274
CU	D	0.545878
CU	D	0.686975
CU	U	0.455757
CU	U	0.518482
CU	U	0.827988

Relative closeness to the ideal solution for [CU+W]

Electrode	Dielectric	Relative closeness
CU+W	K	0.096866
CU+W	K	0.293256
CU+W	K	0.39076
CU+W	D	0.031159
CU+W	D	0.254256
CU+W	D	0.767725
CU+W	U	0.389904
CU+W	U	0.231264
CU+W	U	0.822157

Relative closeness to the ideal solution for [CU]& [CU+W]

Electrode	Dielectric	Relative closeness
CU	K	0
CU	K	0.145782
CU	K	0.30744
CU	D	0.290238
CU	D	0.468076
CU	D	0.612224
CU	U	0.396697
CU	U	0.448818
CU	U	0.772134
CU+W	K	0.145694
CU+W	K	0.309963
CU+W	K	0.439323
CU+W	D	0.120195
CU+W	D	0.320988
CU+W	D	0.788453
CU+W	U	0.438708
CU+W	U	0.304493
CU+W	U	0.845587



Topsis Analysis are summarized as follows:

Sl.No	Array of Experiments	Best Alternative
1	Copper L ₉ [1-9]	Urea solution
2	Copper Tungsten [9-18]	Urea solution
3	Copper & Copper Tungsten [1-18]	Copper Tungsten and Urea solution



CONCLUSION

On the basis of experimental results, the EDM characteristics of Titanium alloy [Ti-6Al-4V] were examined using kerosene, distilled water and urea solution as the dielectrics and Copper and copper Tungsten as electrodes.

- Copper Tungsten electrode gives better MRR while copper performed for lower EWR.
- Urea solution gives better MRR and kerosene is preferred for lower EWR.
- By applying TOPSIS Urea solution and Copper Tungsten electrode gives better results among other alternatives.



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THANK YOU

